

# Search Notes



Application/Control No.

10/653,222

Examiner

Edgardo Ortiz

Applicant(s)/Patent under Reexamination

LI, JIN

Art Unit

2815

## SEARCHED

Class	Subclass	Date	Examiner
257	431	6/05	EO
↓	432	↓	↓
↓	440	↓	↓
↓	233	↓	↓
↓	234	↓	↓

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
FAST Search	6/05	EO